## **APPLICATION DATA SHEET**

Electronic Version v14

Stylesheet Version v14.0

Title of Invention

METHOD OF FABRICATING A SEMICONDUCTOR DEVICE

Application Type : regular, utility
Attorney Docket Number : NAUP0487USA1

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Customer Number: 027765

Continuing Data:

This is a Division of US application number 10/063,307, filed 2002-04-10, now pending.

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as my attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.